

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Olivier RAYSSAC et al. Confirmation No.: 1187  
Application No: 10/775,917 Group Art Unit: 2822  
Filing Date: February 9, 2004 Examiner: M. Trinh  
For: METHOD OF OBTAINING A SELF-SUPPORTED THIN SEMICONDUCTOR LAYER  
FOR ELECTRONIC CIRCUITS Atty. Docket No.: 4717-13100

**AMENDMENT**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the final Office Action dated August 19, 2008, please enter the following amendments and comments into the file of this application.

**Amendments to the claims** are reflected in the complete listing of all claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

No additional fee is believed to be due for this submission. Please charge any required fees to Winston & Strawn LLP Deposit Account No. 50-1814.

DO NOT ENTER: /MT/